## Search Notes



Application/Control No.	Applicant(s)/Patent under Reexamination	
10/594,828	OPOLKA, RAINER	
Examiner	Art Unit	
Y M. Lee	2885	

SEARCHED				
Class	Subclass	Date	Examiner	
362	Updated Search	6/26/2008	YMY	

Class	Subclass	Date	Examiner

SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
NONE	6/26/2008	YMY	